Notice of Allowability	Application No.	lication No. Applicant(s)	
	09/854,190	FUJIOKA ET AL.	
	Examiner	Art Unit	
	Tuan N. Nguyen	2828	
The MAILING DATE of this communication apperature All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIPORT of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in or other appropriate comm IGHTS. This application is:	n this application. If not included unication will be mailed in due course	e. THIS ne initiative
2. The allowed claim(s) is/are <u>1-6</u> .			
3. The drawings filed on 11 May 2001 are accepted by the Ex	kaminer.		
 4. Acknowledgment is made of a claim for foreign priority una) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). * Certified copies not received: 	been received. been received in Application	on No	om the
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	of this communication to file IENT of this application.	e a reply complying with the requirem	ients
5. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give			E OF
6. CORRECTED DRAWINGS (as "replacement sheets") mus (a) including changes required by the Notice of Draftspers 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner's Paper No./Mail Date Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in the Total DEPOSIT OF and/or INFORMATION about the deposit	on's Patent Drawing Review Amendment / Comment on the header according to 37 CF	r in the Office action of he drawings in the front (not the back) R 1.121(d).	
 DEPOSIT OF and/or INFORMATION about the depo- attached Examiner's comment regarding REQUIREMENT 	FOR THE DEPOSIT OF BIO	DLOGICAL MATERIAL.	16
Attachment(s) 1. Notice of References Cited (PTO-892) 2. Notice of Draftperson's Patent Drawing Review (PTO-948) 3. Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	6. ☐ Interview S Paper No. 8), 7. ☐ Examiner's	formal Patent Application (PTO-152) ummary (PTO-413), /Mail Date Amendment/Comment Statement of Reasons for Allowance	

DETAIL ACTION

Response to Amendment

1. In responding to applicant's amendment RCE filed 04/27/2005, claims 1, 4 have been amended.

REASON FOR ALLOWANCE

Allowable Subject Matter

2. The following is an examiner's statement of reasons for allowance - Applicant's response filed on 04/27/2005 has been considered, with respect to claims 1, and 4 the references of the record fail to teach or suggest a cylindrical gas laser and method of constructing the cylindrical gas laser:

Claims 1, 4:

A cylindrical gas laser comprising a ring-shaped trick mirror with an output mirror at center pass part of the light and reflect part of the remaining light, and a pair of cylindrical electrodes of different diameters position concentrically by spacers and positioned away from ends cylindrical electrodes, wherein a W-axicon mirror disposed at one end of the laser having center offset with the trick mirror $X_0 < X_m = 1.1 \ X_0$.

Communication Information

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Tuan N Nguyen whose telephone number is (571) 272-1948. The examiner can normally be reached on M-F.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Harvey Minsun can be reached on (571) 272-1835. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Tuan N. Nguyen

Tuan Paye

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